This concise introduction to modern experimental Surface Physics is based on many years of teaching experience. The authors present an easy to comprehend microscopic description of the phenomena at surfaces of solids.

- ▶ An account of properties and processes at surfaces.
- ▶ From concepts to practical application, from sample preparation to diverse analytic methods and current research.
- Contains preparatory exam questions and answers.



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Contents

Preface — V

Legend — X

Fundamentals

1	Properties of surfaces — 5
1.1	Atomic structure of surfaces — 5
1.1.1	Surface crystallography — 6
1.1.2	Superlattices and superstructures — 10
1.1.3	Surface relaxation — 14
1.1.4	Surface reconstruction — 17
1.2	Electronic structure — 23
1.2.1	Bloch's theorem — 23
1.2.2	Surface Brillouin zone —— 25
1.2.3	Projected bulk band structure — 27
1.2.4	Surface states — 30
1.2.5	Work function —— 35
1.3	Lattice vibrations at surfaces — 37
2	Processes at surfaces — 42
2 2.1	Processes at surfaces — 42 Energy-loss processes of electrons — 42
2.1	Energy-loss processes of electrons —— 42
2.1 2.1.1	Energy-loss processes of electrons —— 42 Energy distribution of scattered electrons —— 43
2.1 2.1.1 2.1.2	Energy-loss processes of electrons —— 42 Energy distribution of scattered electrons —— 43 Inelastic mean free path —— 46
2.1 2.1.1 2.1.2 2.2	Energy-loss processes of electrons —— 42 Energy distribution of scattered electrons —— 43 Inelastic mean free path —— 46 Adsorption, desorption, and diffusion —— 47
2.1 2.1.1 2.1.2 2.2 2.2.1	Energy-loss processes of electrons —— 42 Energy distribution of scattered electrons —— 43 Inelastic mean free path —— 46 Adsorption, desorption, and diffusion —— 47 Adsorption —— 48
2.1 2.1.1 2.1.2 2.2 2.2.1 2.2.2	Energy-loss processes of electrons —— 42 Energy distribution of scattered electrons —— 43 Inelastic mean free path —— 46 Adsorption, desorption, and diffusion —— 47 Adsorption —— 48 Desorption —— 51
2.1 2.1.1 2.1.2 2.2.1 2.2.2 2.2.3	Energy-loss processes of electrons —— 42 Energy distribution of scattered electrons —— 43 Inelastic mean free path —— 46 Adsorption, desorption, and diffusion —— 47 Adsorption —— 48 Desorption —— 51 Diffusion —— 52
2.1 2.1.1 2.1.2 2.2.1 2.2.2 2.2.3 2.3	Energy-loss processes of electrons — 42 Energy distribution of scattered electrons — 43 Inelastic mean free path — 46 Adsorption, desorption, and diffusion — 47 Adsorption — 48 Desorption — 51 Diffusion — 52 Film growth and epitaxy — 54
2.1 2.1.1 2.1.2 2.2.1 2.2.2 2.2.3 2.3.1	Energy-loss processes of electrons — 42 Energy distribution of scattered electrons — 43 Inelastic mean free path — 46 Adsorption, desorption, and diffusion — 47 Adsorption — 48 Desorption — 51 Diffusion — 52 Film growth and epitaxy — 54 Growth modes — 54
2.1 2.1.1 2.1.2 2.2.1 2.2.2 2.2.3 2.3.1 2.3.1 2.3.2	Energy-loss processes of electrons — 42 Energy distribution of scattered electrons — 43 Inelastic mean free path — 46 Adsorption, desorption, and diffusion — 47 Adsorption — 48 Desorption — 51 Diffusion — 52 Film growth and epitaxy — 54 Growth modes — 54 Nucleation — 55

Methods

3	Preparation	of surfaces	65

3.1 Sources of contamination — 65

3.2	Preparation of clean single-crystal surfaces — 66	
3.2.1	Cleaving — 67	
3.2.2	Annealing — 67	
3.2.3	Chemical cleaning — 69	
3.2.4	Sputtering by ions — 70	
3.3	Modification of surfaces — 72	
3.3.1	Adsorbate-covered surfaces — 73	
3.3.2	Layers on surfaces — 73	
4	Diffraction methods — 77	
4.1	Kinematic description of diffraction — 79	
4.2	Diffraction of low-energy electrons — 84	
4.2.1	Experiment — 84	
4.2.2	Geometry of the diffraction pattern — 85	
4.2.3	Quantitative structure analysis — 88	
4.3	Diffraction of high-energy electrons — 93	
4.4	Surface x-ray diffraction — 93	
4.5	Helium diffraction — 95	
4.6	Fine structure of x-ray absorption — 96	
5	Electron spectroscopies — 101	
5.1	Instrumentation — 102	
5.1.1	Electron sources — 102	
5.1.2	Photon sources — 103	
5.1.3	Energy analyzers — 105	
5.1.4	Electron detection — 107	
5.1.5	Modulation technique — 108	
5.2	Element-specific spectroscopy — 109	
5.2.1	X-ray photoelectron spectroscopy — 109	
5.2.2	Core-level shifts — 113	
5.2.3	Auger electron spectroscopy —— 115	
5.2.4	Lineshape of Auger electron spectra —— 118	
5.2.5	Qualitative and quantitative analysis of chemical elements —	- 119
5.3	Determination of surface band structures — 121	
5.3.1	Angle-resolved photoemission — 122	
5.3.2	Inverse photoemission — 127	
5.3.3	Two-photon photoemission —— 128	
5.3.4	Selection rules for photoemission — 130	
5.4	Spectroscopy of surface vibrations — 132	
5.4.1	Fundamentals and experiment —— 132	
5.4.2	Interactions and selection rules —— 133	
5.4.3	Applications — 137	

6	Scanning probe microscopies —— 143
6.1	Principle of scanning probe methods —— 143
6.2	Scanning tunneling microscopy — 144
6.2.1	Topographic images — 146
6.2.2	Tunnel process — 148
6.2.3	Spectroscopy — 151
6.2.4	Applications and other interaction mechanisms — 154
6.3	Atomic force microscopy — 155
6.3.1	Contact AFM — 156
6.3.2	Dynamic AFM — 156
6.3.3	Forces and their effects in AFM —— 158
6.3.4	Applications and other interaction mechanisms —— 160
7	Particle spectroscopies — 162
7.1	Thermal desorption spectroscopy — 162
7.1.1	Fundamentals and experimental setup —— 162
7.1.2	Types of desorption spectra — 164
7.1.3	Evaluation of desorption spectra — 166
7.1.4	Desorption spectra with several maxima — 169
7.2	lon scattering — 170
A	Appendix — 174
A.1	Planes and surfaces of hcp crystals — 174
A.2	Identification of plane groups — 175
A.3	Brillouin zones and mirror planes — 176
A.4	Energies of Auger transitions — 178

Answers to exercise problems and questions —— 179

Acronyms — 185

Index — 187